



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Toru YAMADA

Application No.: 10/582,802

Filed: June 14, 2006

Docket No.: 136170

For: VAPOR PHASE GROWTH APPARATUS AND METHOD OF FABRICATING  
EPITAXIAL WAFER

**NOTICE OF CHANGE OF ADDRESS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please address all future communications in connection with the above-  
identified application to:

**OLIFF & BERRIDGE, PLC  
CUSTOMER NUMBER 25944**

Respectfully submitted,

Ronald R. Snider  
Registration No. 24,962

RRS/scg

Date: February 13, 2008

**OLIFF & BERRIDGE, PLC  
P.O. Box 320850  
Alexandria, Virginia 22320-4850  
Telephone: (703) 836-6400**

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